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CONFIRMATION NO. 1570

SERIAL NUMBER 10/500,931	FILING OR 371(c) DATE 07/08/2004 RULE	CLASS 438	GROUP ART UNIT 2812	ATTORNEY DOCKET NO. 501.43797X00
APPLICANTS Hiroaki Kikuchi, Chitose, JAPAN; Toshiaki Sawada, Koganei, JAPAN; Hirohiko Yamamoto, Hachioji, JAPAN; ** CONTINUING DATA ***** SDF This application is a 371 of PCT/JP03/00068 01/08/2003 ** FOREIGN APPLICATIONS ***** SDF JAPAN 2002-2507 01/09/2002				
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Verified and Acknowledged <i>Staretha</i> Examiner's Signature <i>SDF</i> Initials		STATE OR COUNTRY JAPAN	SHEETS DRAWING 12	TOTAL CLAIMS 13
			INDEPENDENT CLAIMS 8	
ADDRESS 020457				
TITLE A Fabrication Method of A Semiconductor Integrated Circuit Device Semiconductor integrated circuit device manufacturing method				
FILING FEE RECEIVED 1350	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	